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Yutaka Shira Ryota Suewa Junsuke Ton ** CONTINUING D This applicat ** FOREIGN APPL	a, Hiratsuka-shi, JAPAN; lishi, Hiratsuka-shi, JAPAN aka, Hiratsuka-shi, JAPAN nioka, Hiratsuka-shi, JAPA ATA ***********************************	; AN; *	17/2003					
Foreign Priority claimed 35 USC 119 (a-d) conditions yes no Met after met Verified and Alkfwence Acknowledged Examiner's Signature Initials			STATE OR COUNTRY JAPAN	DRAWING CLA		TOTA CLAI 16	MS	INDEPENDENT CLAIMS 7
ADDRESS 24628								
TITLE Single crystal silico	on producing method, singl n, single crystal silicon ing	le crystal si ot, and sin	ilicon wafer p gle crystal si	oroducii licon wa	ng meth afer	od, seed	d crys	tal for producing
FILING FEE FEES: Authority has been given in Paper RECEIVED No to charge/credit DEPOSIT ACCOUNT 1432 No for following:				All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other Credit				